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Docket No.: 83217US1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Richard F Fernsler et al.

Application No.: 10/672,269

Confirmation No.: 8821

Filed: September 26, 2003

Art Unit: 1763

For: Method and apparatus for producing an ion-ion
plasma continuous in time

Examiner: R. R. Bucker

AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Entered with RCE 2/14/16
MW 2/23/16

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated December 22, 2005, finally rejecting claims 1-8, and 14-16, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.